

MENU

SEARCH

INDEX

DETAIL

BACK

3/3



JAPANESE PATENT OFFICE

PATENT ABSTRACTS OF JAPAN

(11)Publication number: 10012124

(43)Date of publication of application: 16.01.1998

(51)Int.Cl.

H01J 1/30

H01J 9/02

(21)Application number: 08161506

(71)Applicant:

NEC CORP

(22)Date of filing: 21.06.1996

(72)Inventor:

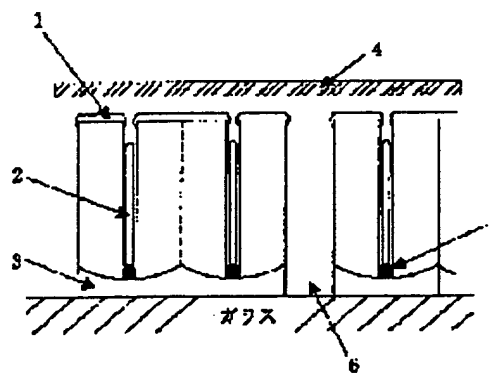
MATSUDATE MASASHIGE

(54) ELECTRON EMISSION ELEMENT AND MANUFACTURE THEREOF

(57)Abstract:

PROBLEM TO BE SOLVED: To provide an electron emission element with its timely stabilized current strength by using a carbon nano-tube for an electron source.

SOLUTION: An alumina layer is provided on a glass substrate in which an aluminum layer 3 is intervened. The alumina layer is provided with fine pores reaching the aluminum layer. For each fine pore, a carbon nano tube 2 grown with a metal catalyst being a starting point exists. Electric power is supplied to this carbon nano tube 2 through a aluminum substrate and functions as an electron source. Since the carbon nano tube 2 is small in curvature radius at a tip end thereof, the electron source with its high electron emission efficiency and superior current strength stability can be manufactured with a



simple process.

LEGAL STATUS

[Date of request for examination]	21.06.1996
[Date of sending the examiner's decision of rejection]	
[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]	
[Date of final disposal for application]	
[Patent number]	3008852
[Date of registration]	03.12.1999
[Number of appeal against examiner's decision of rejection]	
[Date of requesting appeal against examiner's decision of rejection]	
[Date of extinction of right]	

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[MENU](#)[SEARCH](#)[INDEX](#)[DETAIL](#)[BACK](#)